Docket No.: 06920/000J924-US0

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of:

Hiroshi Koshiba

Application No.: 09/975,835

Filed: October 11, 2001

For: SEMICONDUCTOR TEST APPARATUS AND

CONTROL METHOD THEREFOR

Art Unit: 2133

Examiner: J. P. Trimmings

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Technology Center 2100

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated March 29, 2004 (Paper No. 3), please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 4 of this paper and include attached replacement sheets.

Amendments to the Abstract begin on page 5 of this paper.

Remarks/Arguments begin on page 6 of this paper.

Amended drawing Figures are attached following page 9 of this paper.